

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<p style="text-align: center;">O P E INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i></p> <p style="text-align: center;">JUL 12 2004</p> <p style="text-align: center;">PATENT &amp; TRADEMARK OFFICE</p>					Docket Number (Optional) 15689.73	Application Number 09/889,000		
					Applicant(s) Shinji Uebayashi et al.			
					Filing Date June 22, 2004	Group Art Unit 2661		
					U.S. PATENT DOCUMENTS			
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
U.S. PATENT APPLICATION PUBLICATIONS								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
ZH	1	WO 00/27158 ✓	5/11/2000	WIPO	H04Q7	38	✓	
ZH	2	DE 198 30 841 A1 ✓	1/20/2000	German	H04Q7	38	✓	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
EXAMINER	Edwin Hable			DATE CONSIDERED	2/25/05			
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